


<b>Search Notes</b>  	<b>Application/Control No.</b>  10517731	<b>Applicant(s)/Patent Under Reexamination</b>  CHAPEL ET AL.
	<b>Examiner</b>  Rutkowski, Jeffrey M	<b>Art Unit</b>  2419

SEARCHED			
Class	Subclass	Date	Examiner
370	237, 389, 401, 536 (updated search)	04/02/2009	JMR
725	74 (updated search)	04/02/2009	JMR
709	224, 227 (updated search)	04/02/2009	JMR
370	395.64, 536 (updated search)	04/02/2009	JMR
380	217 (updated search)	04/02/2009	JMR
725	95-98 (updated search)	04/02/2009	JMR
370	389 (PID removal concepts)	04/02/2009	JMR
713	201 (PID removal concepts)	04/02/2009	JMR

SEARCH NOTES		
Search Notes	Date	Examiner
searched EAST for PID removal concepts	04/02/2009	JMR

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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